

ABSTRACT

- 5 The invention relates to a process for repairing coated substrate surfaces comprising the following successive steps:
- a) optionally preparing a blemished area to be repaired.
 - b) providing a backing film coated on one side with an uncured or at least partially cured coating layer of a coating composition curable by means of high energy radiation,
 - 10 c) applying the backing film with its coated side onto the blemished area to be repaired,
 - d) irradiating the coating applied in this manner onto the blemished area to be repaired with high energy radiation and
 - 15 e) removing the backing film, wherein
- the coating is irradiated through the backing film and/or after removing the backing film.